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LIGHT SOURCE COMPRISING A PLURALILTY OF MICROSTRUCTURED OPTICAL ELEMENTS

- 5 The invention relates to a light source comprising a microstructured optical element that receives and spectrally spreads the light from a primary light source.
- 10 Patent specification US 6,097,870 discloses arrangement for generating a broadband spectrum in the visible and infrared spectral regions. The arrangement is based on a microstructured fiber into which the light from a pump laser is coupled. The pump light is 15 in the microstructured fiber spread by nonlinear effects. Use is made as microstructured fiber of socalled photonic band gap material or photon crystal fibers. holey fibers or microstructured Configurations as so-called hollow fibers are also 20 known.

A further arrangement for generating a broadband spectrum is disclosed in the publication by Birks et al.: "Supercontinuum generation in tapered fibers"

25 Opt.Lett. Vol. 25, p. 1415 (2000). Use is made in the arrangement of a conventional optical fiber with a fiber core that has a taper at least along a segment. Optical fibers of this type are known as so-called tapered fibers.

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Particularly in microscopy, endoscopy, flow cytometry, chromatography and in lithography, universal illuminating devices of high luminance are important for illuminating the objects. In scanning microscopy, a sample is scanned with a light beam. Lasers are frequently used as light source for this purpose. An arrangement with a single laser emitting a plurality of laser lines, for example, is known from EP 0 495 930:

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"Konfokales Mikroskopsystem für Mehrfarbenfluoreszenz" ["Confocal microscope system for polychromatic fluorescence"]. At present, it is mostly mixed gas lasers, in particular ArKr lasers, that are used. Biological tissues or sections prepared with the aid of for example, dyes, are examined as a In the field of material examination, the sample. illuminating light reflected by the sample is often detected. Use is also frequently made of solid state lasers and dye lasers as well as of fiber lasers and optical parametric oscillators (OPOs) upstream of which a pump laser is arranged.

Laid-open patent application DE 101 15 488 A1 discloses 15 an apparatus for illuminating an object that includes a microstructured optical element that spectrally spreads the light of a laser. The apparatus comprises an optics that shapes the spectrally spread light to form an illuminating light beam. The laid-open patent 20 application also discloses the use of the apparatus for illumination in a microscope, in particular scanning microscope.

15 509 A1 discloses Patent application DE 101 25 arrangement for examining microscopic preparations with the aid of a scanning microscope and of an illuminating for a scanning microscope. The arrangement comprises a laser and an optical means that projects the light generated by the laser onto a sample to be 30 examined. Provided between the laser and the optical means is an optical component that spectrally spreads in the light generated by the laser during a single pass, the optical component consisting of photonic band gap material and preferably being designed as an 35 optical fiber.

The generation of light of a broadband wavelength spectrum from 500 to 1600 nm with the aid of an

air/quartz-glass fiber is exhibited in the article by Ranka et al., Optics Letters, Vol. 25, No. 1.

Apart from depending on the wavelength of the primary light source, the properties of the light generated with the aid of microstructured optical elements, such as photonic crystal fibers, for example, also depend on the parameters of the microstructured optical element such as for example, the zero-dispersion wavelength or the type and the dimensions of the hole structure or 10 microstructure. As a rule, given the same wavelength of the primary light two different photonic crystal fibers a different emission have spectrum. particularly disadvantageous, in particular, with 15 regard to the reproducibility of experiments.

As a rule, the power of the spectrally spread light is distributed in a largely uniform fashion over the entire broad spectral region such that only a relatively slight light power (typically 1-5 mW/nm) is available for applications in which only light of individual wavelengths or light of an individual small wavelength region is required.

- 25 Laid-open patent application DE 100 56 382 A1 discloses a light source for illuminating in scanning microscopy and a scanning microscope. The light source contains an electromagnetic energy source that emits light of one wavelength, and a means for spatially dividing the 30 light into at least two partial light beams. An intermediate element for changing wavelength provided in at least one partial light beam. The light source can be used in STED microscopy.
- In scanning microscopy, a sample is illuminated with a light beam in order to observe the reflected light or fluorescent light emitted by the sample. The focus of an illuminating light beam is moved in an object plane

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with the aid of a controllable beam deflecting device, generally by tilting two mirrors, the deflection axes mostly being perpendicular to one another such that one mirror deflects in the x-direction and, and the other in the y-direction. The tilting of the mirrors is accomplished, for example, with the aid of galvanometer actuating elements. The power of the light coming from the object via a detection beam path is measured with the aid of a detector as a function of the position of the scanning beam. The actuating elements are usually equipped with sensors for determining the current mirror position.

An object is scanned in three dimensions with the focus of a light beam specifically in confocal scanning microscopy.

A confocal scanning microscope generally comprises a light source, an imaging optics with the aid of which 20 the light from the source is focused onto a pinhole diaphragm - the so-called excitation diaphragm - a beam splitter, a beam deflecting device for beam control, a microscope optics, a detection stop and the detectors for detecting the detection light or fluorescent light. The illuminating light is often coupled in via the beam 25 splitter, which can, for example, be designed as a neutral beam splitter or as a dichroic beam splitter. Neutral beam splitters have the disadvantage that a great deal of excitation light or a great deal of 30 detection light is lost depending on the splitting ratio.

The detection light (for example fluorescent light or reflection light) coming from the object passes back via the beam deflecting device to the beam splitter, passes the latter and is subsequently focused onto the detection stop behind which the detectors are located. Detection light that does not originate directly from

the focus region takes a different light path and does not pass the detection stop, and so punctiform information is obtained that leads by means sequential scanning of the object to a threedimensional image. A three-dimensional image is mostly obtained by layerwise image data acquisition, the track scanning light beam ideally describing a meandering line on and/or in the object (scanning a line in the x-direction for a constant y-position, 10 subsequently stopping x-scanning and pivoting y-adjustment to the next line to be scanned and then, for a constant y-position, scanning this line in a negative x-position, etc). In order to enable layerwise image data acquisition, the sample stage or the 15 objective is displaced after the scanning of a layer, and in this way the next layer to be scanned is brought into the focal plane of the objective.

In many applications, samples are prepared with a plurality of markers, for example a plurality of different fluorescent dyes. These dyes can be excited sequentially, for example with the aid of illuminating light beams that have different excitation wavelengths.

25 As is described in European patent EP 0 491 entitled "Doppelkonfokales Rastermikroskop" ["Double confocal scanning microscope"], it is possible achieve an increase in resolution in the direction of the optical axis by means of a double objective 30 arrangement (4Pi arrangement). The light coming from the illuminating system is split into two partial beams that illuminate the sample simultaneously in a fashion running opposite to one another through two objectives arranged with mirror symmetry. The two objectives are arranged on different sides of the object plane common 35 to them. This interferometric illumination forms interference pattern at the object point that exhibits a primary maximum and a plurality of secondary maxima

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in conjunction with constructive interference. By comparison with the conventional scanning microscope, owing to the interferometric illumination an increased axial resolution can be achieved with the aid of a double confocal scanning microscope.

An arrangement for raising the resolving power for fluorescence applications is known from DE 44 16 558. Here, the lateral edge regions of the focus volume of the exciting light beam are illuminated with the aid of light beam of another wavelength, the so-called stimulation light beam, which is emitted by a second laser in order to bring the sample regions excited by the light from the first laser back into the ground state in a stimulated fashion. It is now only the spontaneously emitted light from the regions illuminated by the second laser that is detected, and so an overall improvement in resolution is achieved. The designation of STED (Stimulated Emission Depletion) has been adopted for this method.

A new development has shown that it is possible to achieve an improvement in resolution simultaneously both laterally and axially when success is achieved in hollowing out the focus of the stimulation light beam. To this end, there is introduced into the beam path of the stimulation light beam a round phase delay plate that delays the light waves in subregions by a phase that corresponds to an optical path length of  $\lambda/2$ . The phase delay plate has a diameter smaller than the beam diameter and is therefore overilluminated. In order to achieve a stimulation beam hollow in the inside, the light quantity that experiences a phase delay of  $\lambda/2$  must be equal to the light quantity not delayed.

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STED microscopy is currently being carried out in three different configurations:

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By means of a titanium-sapphire (TiSa) laser for stimulated deenergization of the fluorescent dye, and of an optical parametric oscillator (OPO), pumped by the TiSa, for exciting the fluorescent dye (Proc. Natl. Acad. Sci. U.S.A., Vol. 97, p. 8206-8210, 2000).

By means of two synchronized laser diodes of which one laser diode has a wavelength in the wavelength region of the absorption spectrum of the dye, and the other laser diode has a wavelength in the region of the emission spectrum of the dye (Appl. Phys. Lett., Vol. 82, No. 18, p. 3125-3127, 2003).

By means of a pulsed solid state laser whose light is used, on the one hand, for stimulated deenergization of the fluorescent dye. On the other hand, the light is doubled in frequency and used to excite the dye. (Hell, S.W. (1997). "Increasing the Resolution of Far-Field Fluorescence Microscopy by Point-Spread-Function 20 Engineering." Topics In Fluorescence Spectroscopy 5: Nonlinear and Two-Photon-Induced Fluorescence. J. Lakowicz. New York, Plenum Press. 5.)

Titanium-sapphire lasers, for example, are used 25 light source in STED microscopy in conjunction with the optical parametric oscillators (OPOs). Light sources of this type have the disadvantage that they can make available only light of a very limited wavelength spectrum and that, moreover, they are difficult to 30 operate. The very high procurement price is not the least of the disadvantages with these light sources. Mutually synchronized semiconductor lasers are also currently being used as light sources in STED microscopy, the light power of the laser diode used for stimulated deenergization often disadvantageously not 35 sufficing. Moreover, operation is necessarily restricted to two wavelengths of the laser diodes used. As an alternative, solid state lasers with subsequent frequency doubling are also currently being used in STED microscopy. Two mutually independent wavelengths are hereby necessarily fixed for the light for exciting the sample, and for the light that effects a stimulated emission, and this limits the ability to use this type of light source to a few possible applications.

It is the object of the present invention to specify a light source comprising a microstructured optical element whose emission spectrum is adapted to the respective application, and that can be used, in particular, in scanning microscopy and, specifically, in STED microscopy.

- 15 The object is achieved by means of a light source characterized in that the spectrally spread light traverses at least one further microstructured optical element.
- 20 Owing to the sequential arrangement of two or more microstructured optical elements, the spectral properties of the light emitted by the light source can be influenced and adapted to the requirements of the intended application. In particular, the power of the 25 light emitted by the light source can be increased in spectral subregions that are of particular importance for the application by a suitable selection of the parameters of the microstructured optical element and of the further microstructured optical 30 element. For example, when the light source is used in STED microscopy it is possible to maximize the light power in the region of the absorption spectrum of the sample dyes used and in the region of the emission spectrum of the sample dyes used. The inventive light 35 source is therefore particularly suitable applications in high-resolution microscopy such as, for

example, the abovementioned STED microscopy or in STED-

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scanning microscopy (double confocal scanning microscope), and in CARS microscopy.

The inventive light source can advantageously be used 5 to generate emission light whose spectral width exceeds the spectral width that each individual microstructured optical element would generate. Such a light source is of interest, in particular, for multiwavelength STED applications, since a very wide supercontinuum 10 required here.

In a very particularly preferred variant refinement of the light source, the microstructured optical element and the further microstructured optical element are spliced together. The splicing of optical fibers is a technique adequately known to the person skilled in the art. In laid-open patent application US 2003/0081915 it is described, in addition, how a conventional fiber and a microstructured fiber can be spliced together such 20 that the transmission losses are minimized.

In another preferred variant refinement of the light source, the light that emerges from the microstructured element optical is coupled into the further microstructured optical element by a lens arrangement.

Pump-probe experiments can also be carried efficiently with the aid of the inventive light source.

- 30 The primary light source is preferably a pulsed light source, and comprises in a preferred variant a pulsed laser that can be designed, for example, as a pulsed titanium sapphire laser.
- 35 In a particularly preferred embodiment, a means provided for selecting light components over at least one wavelength and/or at least one wavelength region. These means can be, for example, color filters or

dichroic filters. The means for selection preferably include an acousto-optical or electro-optical component. In a preferred variant, the means for selection is designed as an AOTF (Acousto Optical Tunable Filter) or as an AOBS (Acousto Optical Beam Splitter).

As already mentioned, the light source is also eminently suitable within a method for generating 10 illuminating light for STED microscopy or for pumpexperiments. A light component that has wavelength within the excitation spectrum of respectively used fluorescence dye is hereby split off from the spectrally spread light, emitted by the light 15 source, with the aid of the means for selecting a light component and a further light component, which has a wavelength within the emission spectrum fluorescence dye used, is split up and formed into an illuminating light beam. Whereas the light component 20 that has a wavelength within the excitation spectrum of the fluorescence dye serves to excite the sample in the illuminated region, the light component that has a wavelength within the emission spectrum serves triggering stimulated emission in a sample region 25 partially overlapping the excitation sample region. When the primary light source is a pulsed light source, the pulses in the two split off light components are necessarily mutually synchronized, which is a very important property for STED microscopy.

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The light from the primary light source preferably traverses the microstructured optical element and/or the further microstructured optical element only once. However, a repeated traversal is also possible.

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The microstructured optical element and/or the further microstructured optical element preferably contains photonic band gap material. The microstructured optical

element and/or the further microstructured optical element are/is preferably designed as optical fiber(s) (photonic crystal fiber (PCS); holey fiber, etc).

In another variant, the microstructured optical element configured as an optical fiber has a taper (tapered fiber).

In a preferred embodiment of the scanning microscope, 10 the microstructured optical element and/or the further microstructured optical element is assembled from a multiplicity of micro-optical structural elements that have at least two different optical densities. A very particular preference is for a refinement in which the 15 optical element includes a first region and a second first the region having a homogeneous structure, and a microscopic structure composed micro-optical structural elements is formed second region. It is also advantageous when the second 20 region surrounds the first region. The micro-optical structural elements are preferably cannulars, webs, honeycombs, tubes or cavities.

In a particular variant, the microstructured optical 25 element and/or the further microstructured optical element comprise/comprises glass or plastic material arranged next to one another and cavities. A particular preference is the variant design in microstructured optical element and/or the further 30 microstructured optical element comprise/comprises photonic band gap material and is configured as optical fiber. It is preferred to provide between the laser and the optical fiber an optical diode that suppresses backreflections of the light beam that 35 originates from the ends of the optical fiber.

A design variant that is of very particular preference and easy to implement includes as microstructured

optical element and/or as further microstructured optical element a conventional optical fiber with a fiber core diameter of approximately 9  $\mu$ m that has a taper at least along a segment. Optical fibers of this type are known as so-called tapered fibers. The optical fiber is preferably 1 m long overall and has a taper of a length of 30 mm to 90 mm. In a preferred refinement, the diameter of the entire fiber is approximately 2  $\mu$ m in the region of the taper.

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A further preferred variant embodiment includes a microstructured optical element and a further microstructured optical element in the case of which elements the structural elements merge into one another continuously. In a very particularly preferred variant, a microstructured optical element and a further microstructured optical element are designed as optical fibers with a continuous transition.

20 The inventive light source can also, for example, be used in a flow cytometer or an endoscope or a chromatograph or a lithography apparatus.

The subject matter of the invention is illustrated schematically in the drawing and described below with the aid of the figures, in which:

figure 1 shows an inventive light source,

figure 2 shows a further inventive light source, and

30 figure 3 shows an inventive confocal scanning microscope.

Figure 1 shows an inventive light source 1 having a primary light source 3 that is configured as a pulsed titanium sapphire laser 5. The light 7 from the primary light source is coupled with the aid of the incoupling optics 9 into a microstructured optical element 11 that is designed as a photonic crystal fiber 13. Spliced

directly to the photonic crystal fiber 13 is a further microstructured optical element 15 that is designed as further photonic crystal fiber 17. Following similarly a third and a fourth microstructured optical element 19, 21 are spliced to the third and fourth 5 photonic crystal fibers 23, 25. The spectrally spread light emerging from the fourth photonic crystal fiber 25 is shaped into an illuminating light beam 29 with the aid of the optics 27. The illuminating light beam 10 29 subsequently traverses a means 31 for selecting light components of at least one wavelength and/or at least one wavelength region, which is designed as an AOTF 33. The illuminating light beam 29 emerging from the AOTF 33 now includes only light components of the 15 selected wavelength or of the selected wavelength while the remaining light components regions, directed by the AOTF into a beam trap (not shown). The light source has a housing 35 for the purpose of protection against external influences, in particular 20 protection against contamination.

A further inventive light source is illustrated in figure 2. The light 7 from the primary light source 3 is firstly coupled into a conventional optical fiber 12 25 with the aid of the incoupling optics 9. The conventional optical fiber 12 is spliced to microstructured optical element 11 that is designed as a photonic crystal fiber 13. The light 7 is spectrally spread in the photonic crystal fiber 13 and coupled out 30 of the fiber. The spectrally spread light subsequently coupled with the aid of a lens arrangement 14 into a further microstructured optical element 15, which is equipped as further photonic crystal fiber 17. coupling of two optical fibers to a lens 35 arrangement is standard in fiber optics and can be ready made. Located following the further photonic crystal fiber 17 is a third microstructured element 19 comprising a third photonic crystal fiber 23. In the

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transition region 20, which is illustrated with gradual gray transition, the structural elements merge into one another continuously. After traversing all the optical elements, the light beam has a spectrum in which a particularly large quantity of light has been converted into specific spectral regions by comparison with all the other spectral regions. This spectrally shaped light beam 28 subsequently traverses a means 31 selecting light components of at least wavelength and/or at least one wavelength region, which is designed as an AOTF 33. Subsequently, the spectrally shaped light beam 28 is split with the aid of a beam splitter 36 into an excitation light beam 30 and a stimulation light beam 32. The stimulation light beam 32 traverses a phase delay plate 34 such as is used in STED microscopy. This mode of procedure is adequately known to the person skilled in the art. The two light reunited with one another via a beam beams recombiner 38. As described in figure 3, this light beam can subsequently be coupled as illuminating light beam 29 into an inventive scanning microscope and used for the purpose of STED microscopy.

Figure 3 shows an inventive scanning microscope that is 25 designed as a confocal scanning microscope. illuminating light beam 29 emanating from an inventive source 1 having the microstructured optical elements (not shown in this figure) is focused by the lens 61 onto the illuminating pinhole diaphragm 37 and 30 passes subsequently to the main beam splitter 39, which directs the illuminating light beam 29 to the beam deflecting device 41, which includes a cardanically suspended scanning mirror 43. The beam deflecting device 41 guides the illuminating light beam 29 through 35 the scanning lens 45 and the tube lens 47 as well as through the objective 49 via or through the sample 51. Detection light 53 emanating from the sample and which is illustrated by dashes in the figure passes back, on

the reversed light path, specifically through the objective 49, the tube lens 47 and through the scanning lens 45, to the beam deflecting device 41 and to the main beam splitter 39, passes the latter and, after traversing the detection pinhole diaphragm 55, passes to the detector 57 that is designed as a multiband detector 59. The detection light is detected in various spectral detection channels in the multiband detector 59, and generates electrical signals proportional to the power that are relayed to a processing system (not shown) for displaying an image of the sample 51.

The invention has been described with reference to a particular embodiment. However, it goes without saying that changes and modifications can be carried out without departing in so doing from the scope of protection of the following claims.

## List of reference numerals

- light source
- 3 primary light source
- 5 5 titanium sapphire laser
  - 7 light
  - 9 incoupling optics
  - 11 microstructured optical element
  - 12 conventional optical fiber
- 10 13 photonic crystal fiber
  - 14 lens arrangement
  - 15 further microstructured optical element
  - 16 spectrally spread light
  - 17 further photonic crystal fiber
- 15 19 third microstructured optical element
  - 20 transition region
  - 21 fourth microstructured optical element
  - 23 third photonic crystal fiber
  - 25 fourth photonic crystal fiber
- 20 27 optics
  - 28 spectrally shaped light beam
  - 29 illuminating light beam
  - 30 excitation light beam
  - 31 mean for selecting light components
- 25 32 stimulation light beam
  - 33 AOTF
  - 34 phase delay plate
  - 35 housing
  - 36 beam splitter
- 30 37 illuminating pinhole diaphragm
  - 38 beam recombiner
  - 39 main beam splitter
  - 41 beam deflecting device
  - 43 scanning mirror
- 35 45 scanning lens
  - 47 tube lens
  - 49 objective
  - 51 sample

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- 53 detection light
- 55 detection pinhole diaphragm
- 57 detector
- 59 multiband detector
- 5 61 lens